

Form PTO-1449
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Patent and Trademark Office

Atty Docket 0756-209

Serial No. 09/499,619

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Filing Date: February 07, 2000

Group Art Unit: 2815

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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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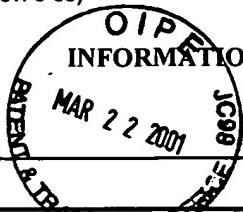
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
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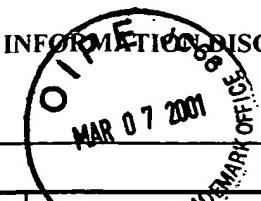
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